



Substitute for Form 1449/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

**Complete if Known**

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|------------------------|----------------|
| Application Number     | 10/082,397     |
| Filing Date            | August 6, 2002 |
| First Named Inventor:  | Mark W. Miles  |
| Art Unit               | 2873           |
| Examiner Name          | Mai, Huy Kim   |
| Attorney Docket Number | 005652.P013XCD |

Sheet

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**U.S. PATENT DOCUMENTS**

| Examiner Initials* | Cite No. <sup>1</sup> | Document Number                          |              | Publication Date<br>MM-DD-YYYY | Name of Patentee or<br>Applicant of Cited Document | Pages, Columns, Lines,<br>Where Relevant<br>Passages or Relevant<br>Figures Appear |
|--------------------|-----------------------|--|--------------|--------------------------------|--|--|
|                    |                       | Number-Kind Code <sup>2</sup> (If known) |              |                                |  |  |
| HM                 |                       | US-                                      | 4,900,395    | 2/13/90                        | Syverson et al.                                    |  |
| HM                 |                       | US-                                      | 5,293,272    | 3/8/94                         | Jansson et al.                                     |  |
| HM                 |                       | US-                                      | 5,358,601    | 10/25/94                       | Cathey   |  |
| HM                 |                       | US-                                      | 5,726,480    | 3/10/98                        | Pister   |  |
| HM                 |                       | US-                                      | 5,793,504    | 8/11/98                        | Stoll  |  |
| HM                 |                       | US-                                      | 5,808,780    | 9/15/98                        | McDonald   |  |
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|                    |                       | US-                                      |              |                                |  |  |
|                    |                       | US-                                      |              |                                |  |  |
|                    |                       | US-                                      |              |                                |  |  |
|                    |                       | US-                                      |              |                                |  |  |

**FOREIGN PATENT DOCUMENTS**

| Examiner<br>Initials* | Cite<br>No. <sup>1</sup> | Foreign Patent Document   |                     |                                      | Publication<br>Date<br>MM-DD-YYYY | Name of Patentee or<br>Applicant of Cited Document | Pages, Columns,<br>Lines, Where Relevant<br>Passages or Relevant<br>Figures Appear | T <sup>6</sup> |
|-----------------------|--------------------------|---------------------------|---------------------|--------------------------------------|-----------------------------------|--|--|----------------|
|                       |                          | Country Code <sup>3</sup> | Number <sup>4</sup> | Kind Code <sup>5</sup><br>(if known) |                                   |  |  |                |
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Examiner  
Signature

Mai

Date Considered

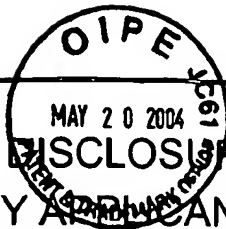
7/12/04

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| Sheet  | 2                    | of   | 2 | Attorney Docket Number   |                | 005652.P013XCD |
| <b>NON PATENT LITERATURE DOCUMENTS</b>   |                      |  |   |                          |                |                |
| Examiner Initials*   | Cite No <sup>1</sup> | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published |   |                          |                | T <sup>2</sup> |
| hm   |                      | IBBOTSON, et al. "Comparison of XeF <sub>2</sub> and F-atom reactions with Si and SiO <sub>2</sub> ", Applied Physics Letters. Vol. 44, No. 12, June 1984. pp 1129-1131.   |   |                          |                |                |
| hm   |                      | SCHNAKENBERG, et al. "Tmahw Etchants for Silicon Micromachining". 1991 International Conference on Solid State Sensors and Actuators - Digest of Technical Papers. pp. 815-818.  |   |                          |                |                |
| hm   |                      | WILLIAMS, et al. "Etch Rates for Micromachining Processing", Journal of Microelectromechanical Systems. Vol. 5 No. 4, December 1996, pp 256-269.   |   |                          |                |                |
| hm   |                      | WINTERS, et al., "The etching of silicon with XeF <sub>2</sub> vapor". Applied Physics Letters, Vol. 34. No. 1, Jan. 1979, pp. 70-73.  |   |                          |                |                |
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